

Searches for User *gverbitsky* (Count = 37661)

Queries 37612 through 37661.

Find

S #	Updt	Database	Query	Time	Comment
<u>S37661</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/185 and (substrate resistance or substrate resistor)) and (membrane or diaphragm)	2006- 01-19 16:51:13	
<u>S37660</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/185) and (substrate resistance or substrate resistor)	2006- 01-19 16:46:38	
<u>S37659</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	374/185	2006- 01-19 16:46:08	
<u>S37658</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	((MEMBRANE OR DIAPHRAGM) adj5 (resistance)) and (substrate adj5 resistance)	2006- 01-19 16:05:25	
<u>S37657</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(MEMBRANE OR DIAPHRAGM) adj5 (resistance)	2006- 01-19 16:04:58	
<u>S37656</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/29 and (substrate or wafer)) and (MEMBRANE OR DIAPHRAGM)	2006- 01-19 15:53:29	
<u>S37655</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/29) and (substrate or wafer)	2006- 01-19 15:23:21	
<u>S37654</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	374/29	2006-	

			01-19
			15:23:05
<u>S37653</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls. and (MEMS) and (substrate or wafer or silicon)) and (disphragm or membrane)	2006-01-19 15:13:32
<u>S37652</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls. and (MEMS)) and (substrate or wafer or silicon)	2006-01-19 15:13:05
<u>S37651</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls.) and (MEMS)	2006-01-19 15:12:44
<u>S37650</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD bulk adj5 silicon	2006-01-19 15:12:11
<u>S37649</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD bulk silicon resistance	2006-01-19 15:09:31
<u>S37648</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD bulk substrate resistance	2006-01-19 15:08:36
<u>S37647</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (diaphragm temperature or temperature diaphragm) and (substrate temperature or temperature substrate or wafer temperature or temperature wafer)	2006-01-19 14:34:52
<u>S37646</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD ((diaphragm resistance or resistance diaphragm) and (substrate resistance or resistance substrate or wafer resistance or resistance wafer)) and (temperature)	2006-01-19 14:26:34

<u>S37645</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (diaphragm resistance or resistance diaphragm) and (substrate resistance or resistance substrate or wafer resistance or resistance wafer)	2006-01-19 14:23:27
<u>S37644</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD ((diaphragm resistance)) and (substrate resistance)	2006-01-19 14:21:27
<u>S37643</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (diaphragm resistance)	2006-01-19 14:21:10
<u>S37642</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls. and (temperature sens\$4 resist\$4 or temperature measur\$4 resist\$4) and (substrate or wafer)) and (diaphragm)	2006-01-19 13:38:19
<u>S37641</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls. and (temperature sens\$4 resist\$4 or temperature measur\$4 resist\$4) and (substrate or wafer)) and (membrane or diaphragm)	2006-01-19 13:38:00
<u>S37640</u>	<u>U</u>	USPT 5177696.pn. and (second temperature or second resist\$4)	2006-01-19 13:26:14
<u>S37639</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls. and (temperature sens\$4 resist\$4 or temperature measur\$4 resist\$4)) and (substrate temperature or	2006-01-19 12:53:20

		substrate resistance)	
<u>S37638</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls. and (temperature sens\$4 resist\$4 or temperature measur\$4 resist\$4) and (substrate or wafer)) and (membrane or frame)	2006- 01-19 12:26:04
<u>S37637</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls. and (temperature sens\$4 resist\$4 or temperature measur\$4 resist\$4)) and (substrate or wafer)	2006- 01-19 12:25:51
<u>S37636</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (374/\$.ccls.) and (temperature sens\$4 resist\$4 or temperature measur\$4 resist\$4)	2006- 01-19 12:25:17
<u>S37635</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (membrane resistor or resistor membrane) and (substrate resistor or wafer resistor)	2006- 01-19 12:05:58
<u>S37634</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (membrane resistance or resistance membrane) and (substrate resistance or wafer resistance)	2006- 01-19 11:42:41
<u>S37633</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD (resistance membrane) and (resistance substrate or resistance wafer)	2006- 01-19 11:39:59
<u>S37632</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD resistance membrane	2006- 01-19 11:39:41
<u>S37631</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD thermistor on membrane	2006- 01-19

<u>S37630</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	wafer resist\$4 and membrane resist\$4	11:39:21 2006- 01-19 11:38:17
<u>S37629</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(temperature measur\$3 wafer) and "membrane"	2006- 01-19 11:37:47
<u>S37628</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	temperature measur\$3 wafer	2006- 01-19 11:30:05
<u>S37627</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	temperature measur\$3 substrate	2006- 01-19 11:17:15
<u>S37626</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/\$.ccls. and (substrate adj temperature)) and (membrane adj5 temperature or temperature adj5 membrane)	2006- 01-19 11:13:03
<u>S37625</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/\$.ccls. and (substrate adj temperature)) and (mebrane adj5 temperature or temperature adj5 membrane)	2006- 01-19 11:09:30
<u>S37624</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/\$.ccls.) and (substrate adj temperature)	2006- 01-19 11:08:52
<u>S37623</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/\$.ccls. and (temperature adj5 substrate)) and (membrane adj5 temperature)	2006- 01-19 11:00:49
<u>S37622</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/\$.ccls. and (temperature adj5 substrate)) and (temperature adj membrane)	2006- 01-19 11:00:24
<u>S37621</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(374/\$.ccls.) and (temperature adj5 substrate)	2006- 01-19 10:59:50
<u>S37620</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(substrate temperature and (membrane temperature)) and (resist\$4)	2006- 01-19 10:30:09
<u>S37619</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(substrate	2006-

			temperature) and	01-19
			(membrane	10:29:35
			temperature)	
<u>S37618</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	substrate	2006-
			temperature	01-19
				10:29:19
<u>S37617</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor and	2006-
			(substrate	01-19
			resist\$4)) and	10:23:10
			(membrane)	
<u>S37616</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor)	2006-
			and (substrate	01-19
			resist\$4)	10:20:54
<u>S37615</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor and	2006-
			(substrate)) and	01-19
			(membrane)	10:19:58
<u>S37614</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor)	2006-
			and (substrate)	01-19
				10:19:48
<u>S37613</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	(mem sensor)	2006-
			and (374/\$.ccls.)	01-19
				10:19:14
<u>S37612</u>	<u>U</u>	PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD	mem sensor	2006-
				01-19
				10:18:59

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DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ

<u>L13</u>	substrate resist\$4 same membrane resist\$4	3	<u>L13</u>
<u>L12</u>	substrate resist\$4 same diaphragm resist\$4	0	<u>L12</u>
<u>L11</u>	substrate resistir adj5 membrane resistor	0	<u>L11</u>
<u>L10</u>	substrate resistance adj5 membrane resistance	0	<u>L10</u>
<u>L9</u>	membrane in series substrate or substrate in series membrane	0	<u>L9</u>
<u>L8</u>	L7 and (membrane or diaphragm)	3	<u>L8</u>
<u>L7</u>	L6 and (substrate resistance or substrate resistor)	17	<u>L7</u>
<u>L6</u>	374/185	616	<u>L6</u>
<u>L5</u>	L4 and (substrate adj5 resistance)	276	<u>L5</u>
<u>L4</u>	(MEMBRANE OR DIAPHRAGM) adj5 (resistance)	11487	<u>L4</u>
<u>L3</u>	L2 and (MEMBRANE OR DIAPHRAGM)	7	<u>L3</u>
<u>L2</u>	L1 and (substrate or wafer)	74	<u>L2</u>
<u>L1</u>	374/29	293	<u>L1</u>

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<small>side by side</small>			
	<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<u>L43</u>	L40 and (substrate temperature or substrate resistance)	16	<u>L43</u>
<u>L42</u>	L41 and (membrane or frame)	19	<u>L42</u>
<u>L41</u>	L40 and (substrate or wafer)	95	<u>L41</u>
<u>L40</u>	L1 and (temperature sens\$4 resist\$4 or temperature measur\$4 resist\$4)	391	<u>L40</u>
<u>L39</u>	(membrane resistor or resistor membrane) and (substrate resistor or wafer resistor)	14	<u>L39</u>
<u>L38</u>	(membrane resistance or resistance membrane) and (substrate resistance or wafer resistance)	16	<u>L38</u>
<u>L37</u>	L36 and (resistance substrate or resistance wafer)	7	<u>L37</u>
<u>L36</u>	resistance membrane	1689	<u>L36</u>
<u>L35</u>	thermistor on membrane	0	<u>L35</u>
<u>L34</u>	wafer resist\$4 and membrane resist\$4	4	<u>L34</u>
<u>L33</u>	L32 and "membrane"	0	<u>L33</u>
<u>L32</u>	temperature measur\$3 wafer	53	<u>L32</u>
<u>L31</u>	temperature measur\$3 substrate	53	<u>L31</u>

<u>L30</u>	L28 and (membrane adj5 temperature or temperature adj5 membrane)	6	<u>L30</u>
<u>L29</u>	L28 and (mebrane adj5 temperature or temperature adj5 membrane)	5	<u>L29</u>
<u>L28</u>	L1 and (substrate adj temperature)	290	<u>L28</u>
<u>L27</u>	L25 and (membrane adj5 temperature)	14	<u>L27</u>
<u>L26</u>	L25 and (temperature adj membrane)	0	<u>L26</u>
<u>L25</u>	L1 and (temperature adj5 substrate)	627	<u>L25</u>
<u>L24</u>	L23 and (resist\$4)	17	<u>L24</u>
<u>L23</u>	L22 and (membrane temperature)	22	<u>L23</u>
<u>L22</u>	substrate temperature	41448	<u>L22</u>
<u>L21</u>	L20 and (membrane)	2	<u>L21</u>
<u>L20</u>	L16 and (substrate resist\$4)	4	<u>L20</u>
<u>L19</u>	L18 and (membrane)	169	<u>L19</u>
<u>L18</u>	L16 and (substrate)	562	<u>L18</u>
<u>L17</u>	L16 and L1	1	<u>L17</u>
<u>L16</u>	mem sensor	807	<u>L16</u>
<u>L15</u>	L1 amd (MEM)	0	<u>L15</u>
<u>L14</u>	(substrate adj5 resistance) and (membrane adj5 resistance) and (temperature sensor or temperature indicator or thermal sensor)	7	<u>L14</u>
<u>L13</u>	(substrate resistance) and (membrane resistance) and (temperature sensor or temperature indicator or thermal sensor)	2	<u>L13</u>
<u>L12</u>	L1 and (temperature sens\$3 substrate)	18	<u>L12</u>
<i>DB=USPT; PLUR=YES; OP=ADJ</i>			
<u>L11</u>	6131453.pn.	1	<u>L11</u>
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>			
<u>L10</u>	L9 and (membrane adj5 resistance)	0	<u>L10</u>
<u>L9</u>	L1 and (substrate adj5 resistance)	83	<u>L9</u>
<u>L8</u>	L1 and (substrate resistance)	11	<u>L8</u>
<u>L7</u>	L6 and (substrate)	1	<u>L7</u>
<u>L6</u>	L1 and (membrane resistance)	3	<u>L6</u>
<u>L5</u>	L3 and (membrane resistance)	0	<u>L5</u>
<u>L4</u>	L3 and (membrane)	83	<u>L4</u>
<u>L3</u>	L2 and (substrate)	927	<u>L3</u>
<u>L2</u>	L1 and (temperature sens\$3)	7420	<u>L2</u>
<u>L1</u>	374/\$.ccls.	28929	<u>L1</u>

END OF SEARCH HISTORY